



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Shunji KAMIJIMA et al.

Group Art Unit: 2874

Application No.: 09/581,313

Examiner: J. Kang

Filed: June 12, 2000

Docket No.: 105955

For: MICROMACHINE AND MANUFACTURING METHOD THEREFOR

AMENDMENT

Director of the U.S. Patent and Trademark Office  
Washington, D.C. 20231

Sir:

In reply to the Office Action mailed January 22, 2002, and further to an April 18 personal interview with Examiner Kang, the period for reply being extended by the attached Petition for Extension of Time, please amend the above-identified application as follows:

IN THE DRAWINGS:

Please see the attached Request for Approval of Drawing Corrections.

IN THE SPECIFICATION:

Page 19, lines 17-21, delete current paragraph and insert therefor:

B1  
Next, a method of manufacturing the spatial light modulator 110 is described hereunder with particular emphasis on the optical switching elements 100. Especially, the drive portion 140 and the switching portion 130 of the optical switching elements 100 are manufactured by performing the micromachine manufacturing method of the present invention, which is described in detail hereinbelow.

#113  
D. Scott  
5-22-02

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